



LAAS-CNRS



# Nouvelle approche pour la simulation de la croissance de couches de matériaux réactifs : Monte Carlo cinétique à trajectoires d'atomes hyperthermiques

Anne Hémercyck

Alain Estève, Mehdi Djafari Rouhani,  
Marie Brut, Georges Landa

Cloé Lanthony, Darius Djafari Rouhani

Collaboration expérimentale : Carole Rossi

Collaboration : Nicolas Richard 

## LAAS-CNRS

### LAAS is a CNRS unit located in Toulouse (France) associated with

Université Paul Sabatier (UPS), Institut National des Sciences Appliquées de Toulouse (INSA),  
 Institut National Polytechnique de Toulouse (INP),  
 Institut Supérieur de l'Aéronautique et de l'Espace (ISAE)  
 Université du Mirail (UTM) and Université Toulouse 1 Capitole (UT1)



Feb. 2013 :

#### 624 persons work in LAAS

Researchers and Faculty Members: 501

*91 CNRS researchers*

*128 Faculty researchers*

*9 Associated Researchers*

*30 Post-doc – 243 PhD Students*

Engineers, Technicians, Admin Clerks (ITA): 123

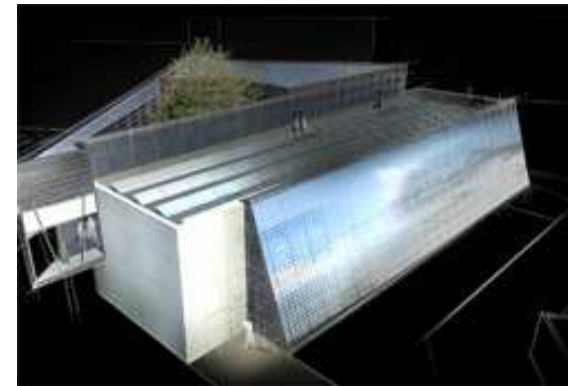
### Scientific Research in 8 main research areas

Critical Information Processing  
 Networks and Communications  
 Robotics  
 Decision and Optimization  
 MicroNanosystems RF and Optical  
 Nano-Engineering and Integration  
 Energy Management  
 MicroNanoBio Technologies

A  
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### 2 Transversal axes



various application domains such as aeronautics and space, telecommunications, transports, production, services, security and defense, energy management, healthcare, cyber security, environment and sustainable development.

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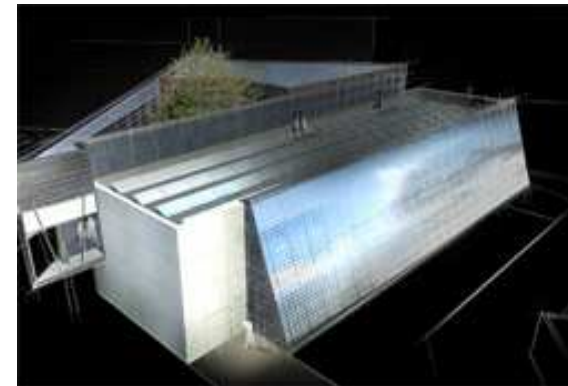
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Atomic Scale Modeling and Simulation  
for Micro, Nano and BioNano Technologies

**Members:**

-2CR, 1MdC, 1DR, 1 Prof  
-1 doc, 1 PostDoc

Atomic Scale Modeling and Simulation  
for Micro, Nano and BioNano Technologies

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➤ **To develop models to address**

- **Nano Engineering for Biology, Health and Human Aging**
- **Nano Engineering for Advanced Microsystems**

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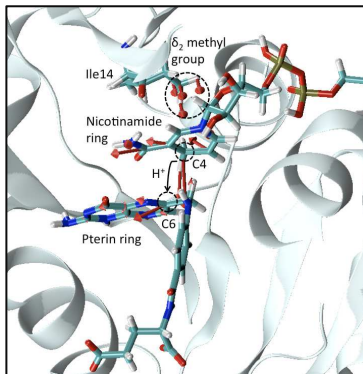
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### Biology, Health

β Amyloid  
DHFR

HIV-1 protease

**Structural Oncology**  
(Ras protein)



### BioTechnologies

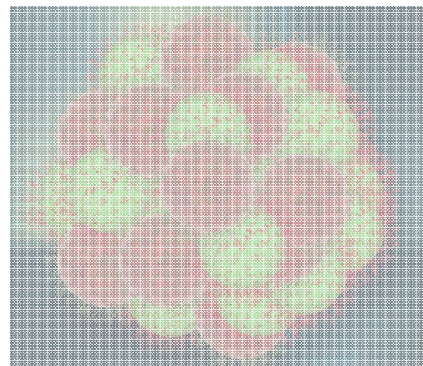
SAMs

vdW interactions

**DNA Technologies**

(DNA assembled

Nanoparticles, Aptamers)



### Oxides (*materials*) encountered in Microelectronics

SiO<sub>2</sub>,

Hig-k (HfO<sub>2</sub>, ZrO<sub>2</sub>)

Si nanodots

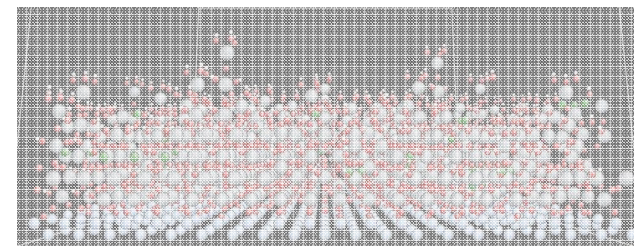
Ge condensation

SiGe, SiC oxidations

Al oxidation

**Reactive materials**

(Al/CuO, AlNi, ... SiO<sub>2</sub>)



## Atomic Scale Modeling and Simulation for Micro, Nano and BioNano Technologies

### Characterizing biomolecular flexibility, docking

(Collab. Stanford Univ., M. Levitt; INRIA, N. Redon)

➤ **Development of original modeling approach - Static Modes** Eur. Phys. J. E **28**, 17 (2009)

➤ **Structural oncology modelling and simulation platform**

(SAMO RITC Project: RAS oncoprotein - Collab. Claudius Regaud Institute, G. Favre)

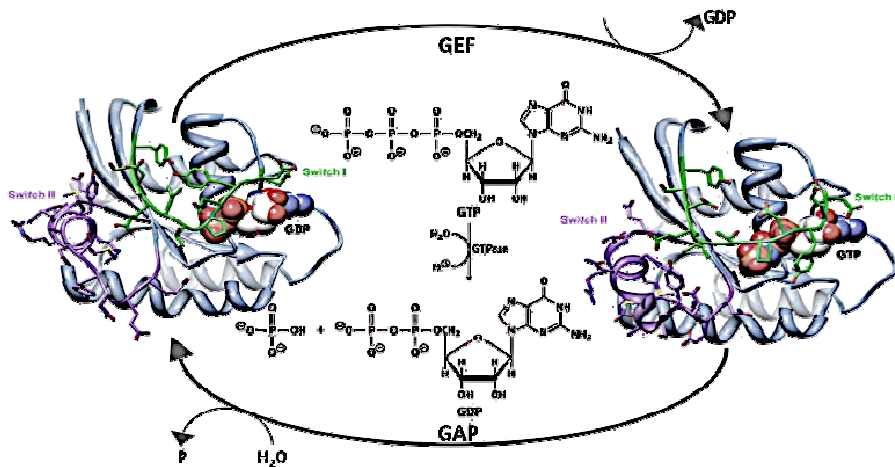
**Providing a new expertise and modelling facilities  
to achieve physico-chemical characterization of  
oncomolecules**

#### Objective

- restoring Ras switching mechanism (GTP hydrolysis / GAP interaction)
- preventing Ras from binding its effectors

#### Using Static Modes as a “probe” to:

- Exploring Ras biomechanical properties
- Screening of mutation impact
- Proposing custom design modifications
- Building a Static Mode databank
- Authorizing end users to custom *in silico* experiments
- Guide mutation experiments



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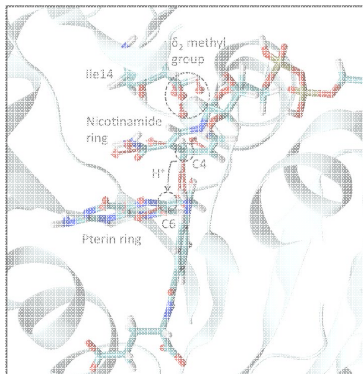
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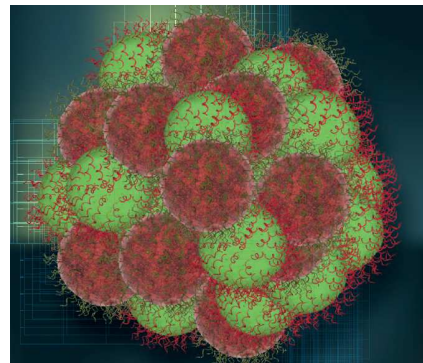


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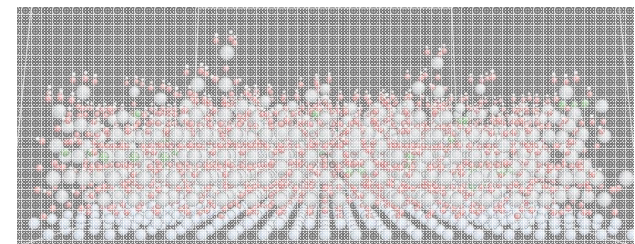


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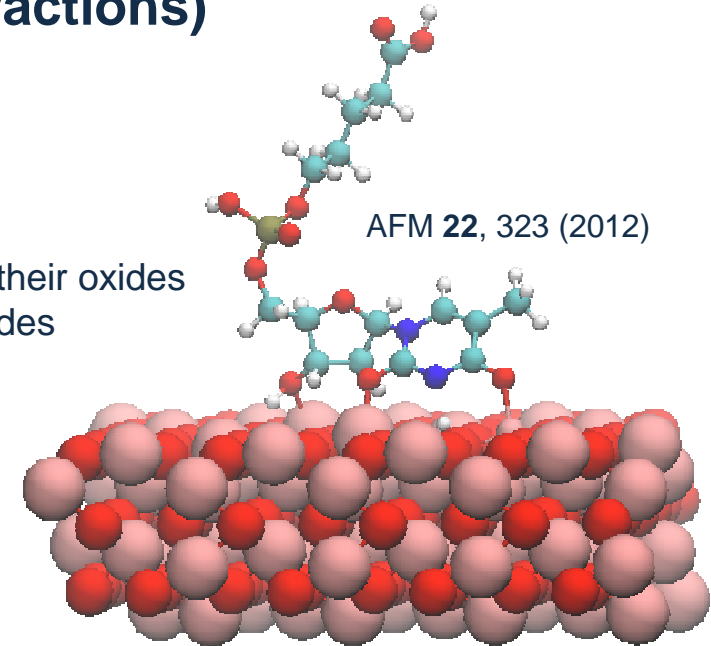


# Atomic Scale Modeling and Simulation for Micro, Nano and BioNano Technologies

## DNA Nanotechnologies (bio/non bio interactions)

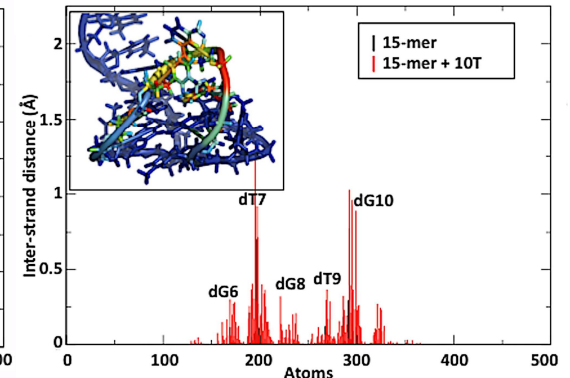
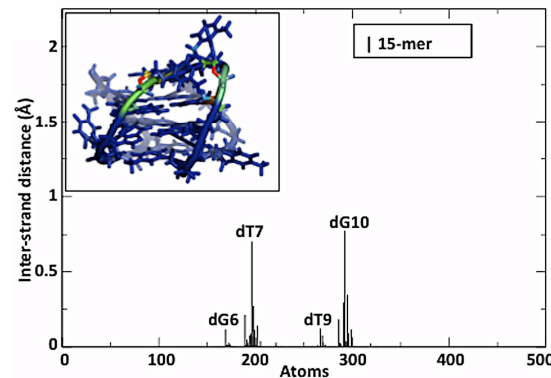
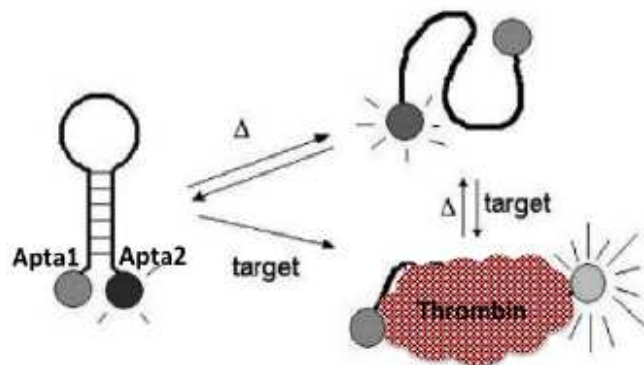
### ➤ Self-assembly and chemistry of DNA/surface and nanoparticles interactions

- Thiol or COOH DNA terminations on Au, Al, Cu surfaces and their oxides
- Intrinsic DNA interactions on Au, Al, Cu surfaces and their oxides
- Role of London interactions on DNA/Surface interactions



### ➤ Aptamer sensors (ANR VIBBnano)

- Impact of aptamer spacer termination on aptamer stability
- Design of aptamer tweezers



APL 100, 163702 (2012)

# Atomic Scale Modeling and Simulation for Micro, Nano and BioNano Technologies

## ➤ To develop models to address

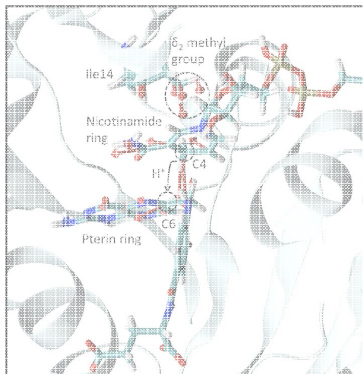
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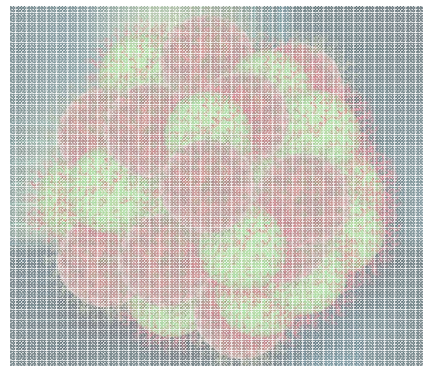
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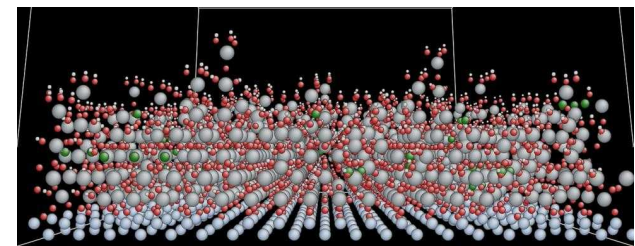
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(Al/CuO, AlNi, ... SiO<sub>2</sub>)



Growth of **reactive materials**

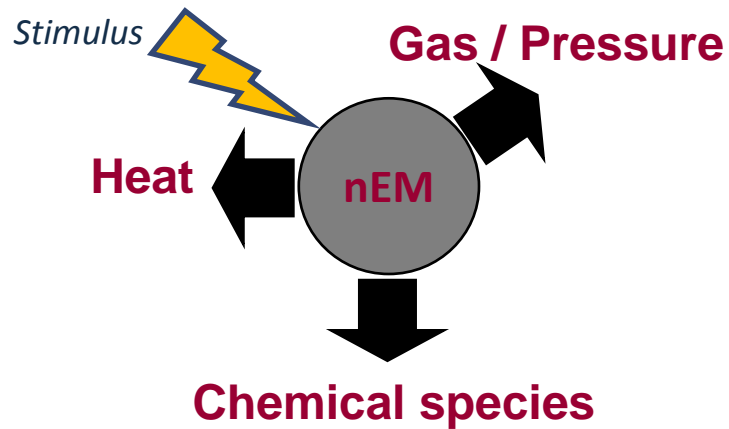
Kinetic Monte Carlo with Hot Atoms Trajectories

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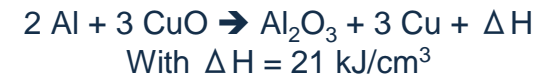
# Growth of reactive materials Kinetic Monte Carlo with Hot Atoms Trajectories

## Context

### ➤ NanoEnergetic Materials



Bimetallics: Al/Ni  
Thermite: Al / CuO

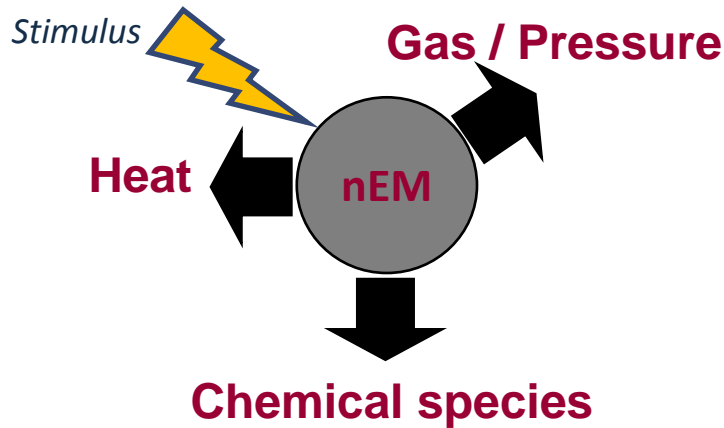


Compatible with technologies  
Integration towards “on a chip” nanoenergetics)

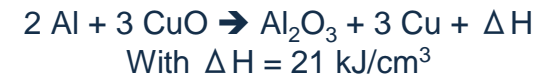
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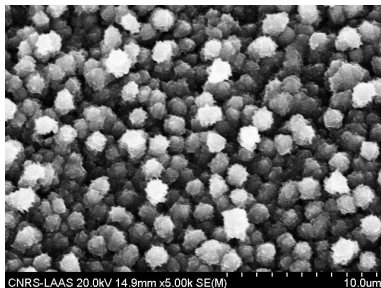


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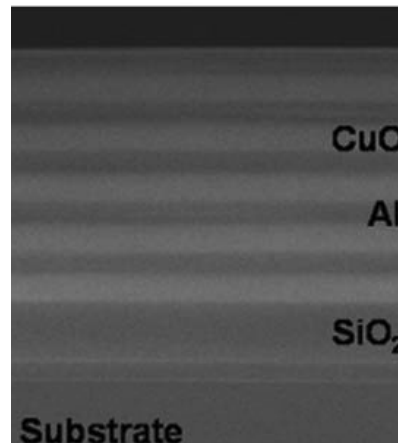


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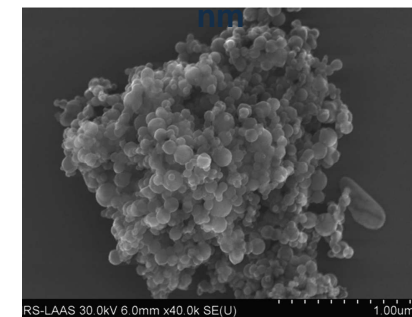
Al/CuO NWs



Al/CuO NLs  
~ 50-100 nm/layer

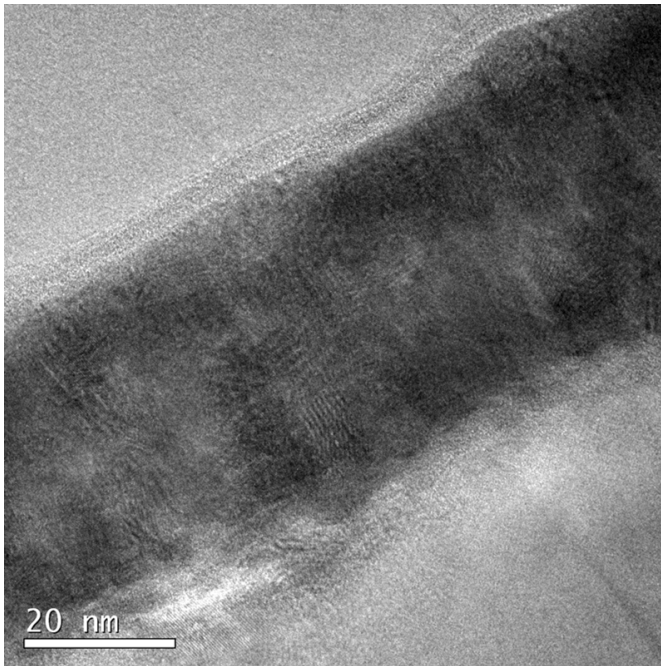


Al/CuO NPs  
Ø ~ 50-120



Growth of reactive materials  
Kinetic Monte Carlo with Hot Atoms Trajectories

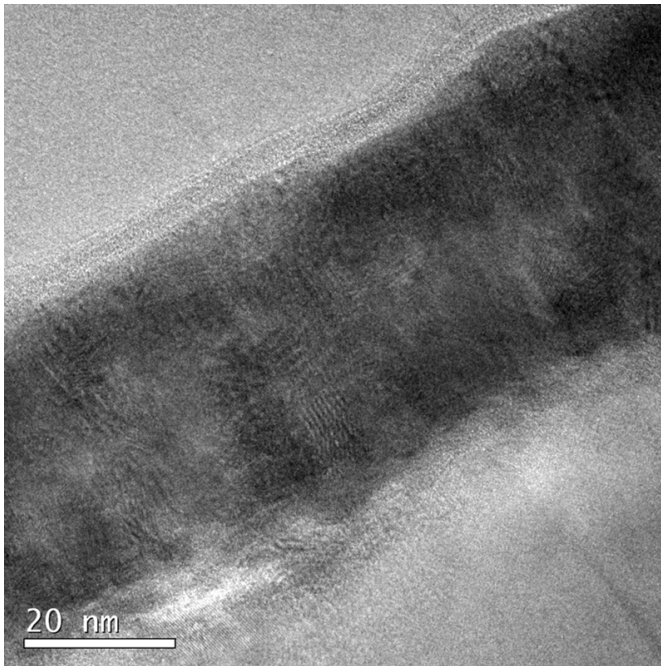
## Technological & scientific Issue: interfacial premixing



- Called Barrier layers
  - Define final properties (stability, reactivity, sensitivity, released Energy)
  - **Formation still not controlled during deposition process (and asymmetric)**
- Final properties neither not mastered nor guaranteed

Growth of reactive materials  
Kinetic Monte Carlo with Hot Atoms Trajectories

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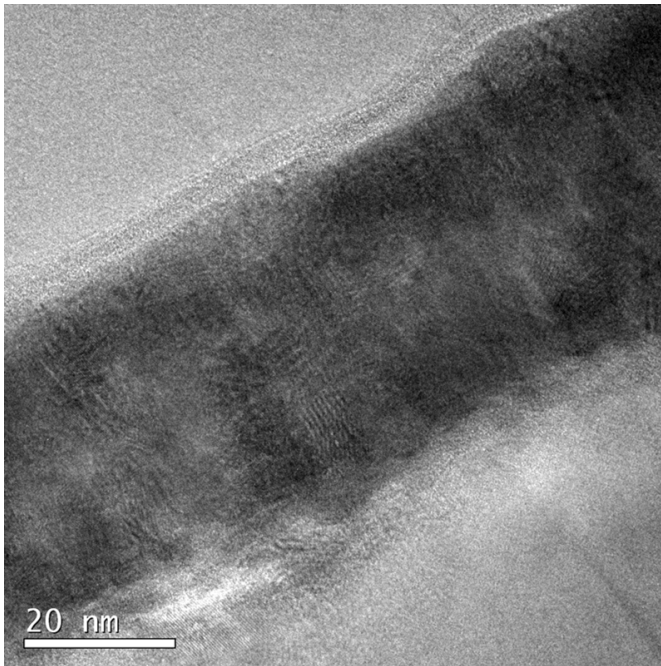


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Growth of reactive materials  
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Process requires **MODELING**

NanoLayers requires **ATOMIC SCALE**

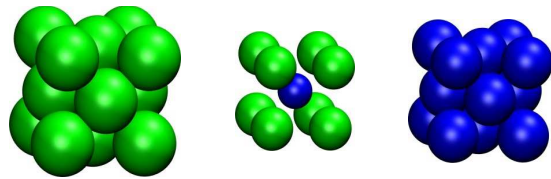
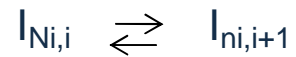
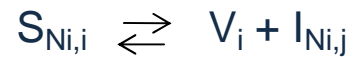


# Growth of reactive materials Kinetic Monte Carlo with Hot Atoms Trajectories

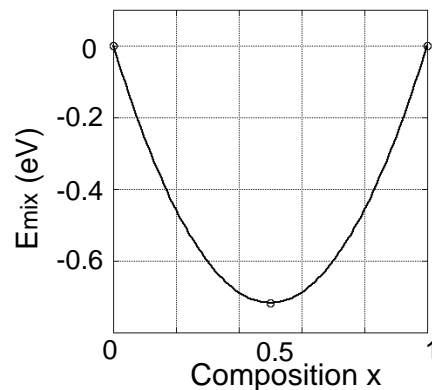
## Preliminary studies on bimetallics Al/Ni

### ◆ Basics from DFT:

$S_{Al}$ ,  $S_{Ni}$ ,  $V$ ,  $I_{Ni}$ ,  $I_{Al}$



$$E_{\text{Mix}}(x) = 2.865 x^2 - 2.865 x$$

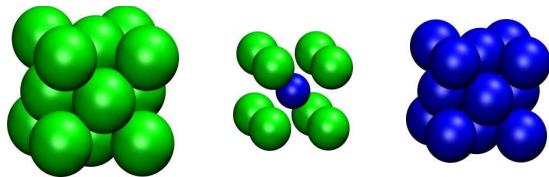
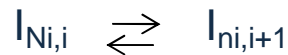
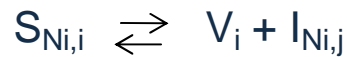


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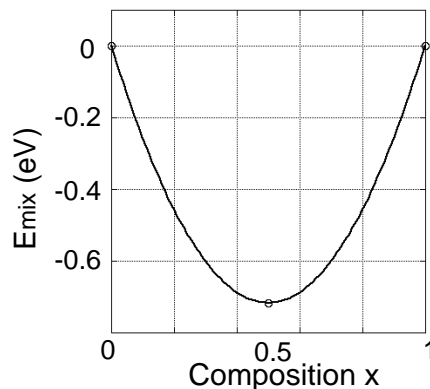
## Preliminary studies on bimetals Al/Ni

### ◆ Basics from DFT:

$S_{Al}, S_{Ni}, V, I_{Ni}, I_{Al}$



$$E_{Mix}(x) = 2.865x^2 - 2.865x$$



◆ Macroscopic 1D model of atomic mix according to chemical kinetics

◆ Environment dependent rate equation formulation

◆ Mixing releases energy that translate into a temperature increase

◆ **Kinetic part:** *Time evolution*  
4 differential equations with RK4-5 scheme and a dynamic time step

$$k_i = \frac{k_B T}{h} \times \exp\left(\frac{-\Delta E_i}{k_B T}\right)$$

### ◆ Energetic part:

*Link between composition and energetic parameters (activation energies, rate constants & released energy using DFT calcul.)*

$$E_{system} = \sum E_{layer}$$

$$E_{layer} = [L(Al)] \times E_{Al} + [L(Ni)] \times E_{Ni}$$

$$+ ([L(Al)] + [L(Ni)]) \times E_{Mix}(x) + [I(Ni)] \times E_{INi}(x) + [V] \times E_V(x)$$

### ◆ Thermal part:

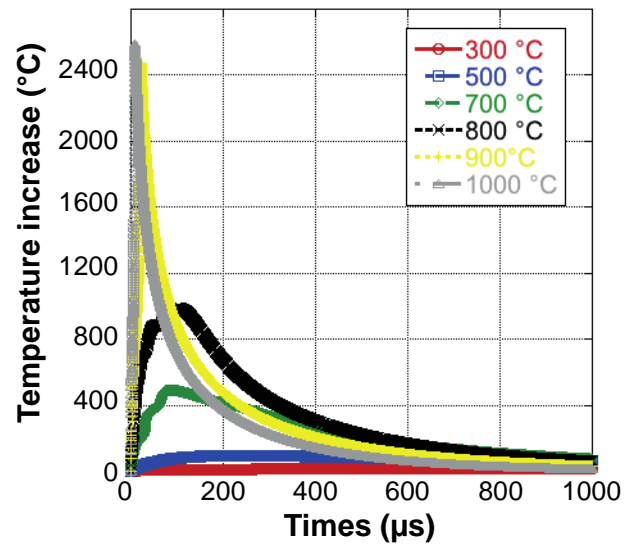
*Translate energy changes into temperature changes*

$$\Delta T = \frac{-\Delta E - dt \times (P_{rad} + P_{conv})}{3k_b \times \sum_i (n_i(L_{Al}) + n_i(L_{Ni}) + n_i(I_{Ni}))}$$

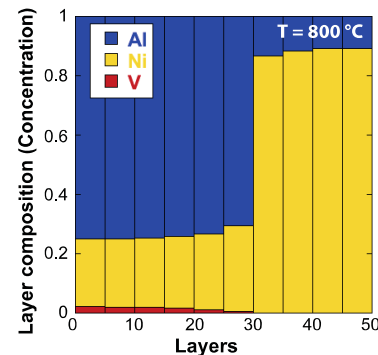
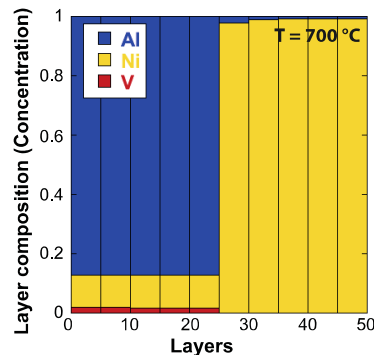
# Growth of reactive materials Kinetic Monte Carlo with Hot Atoms Trajectories

## Preliminary studies on bimetallics Al/Ni

### ◆ Ignition Temperature



### ◆ Layers composition

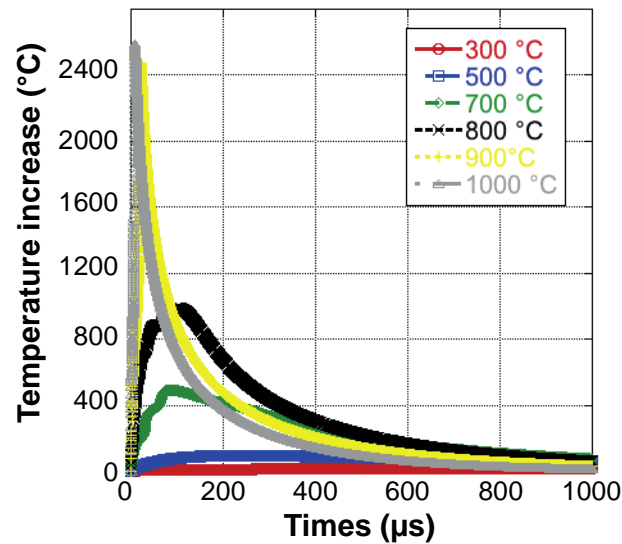


JVST A **28**, L15 (2010)  
 JPCS **71**, 130 (2010)  
 JPCS **71**, 125 (2010)  
 En review à JAP

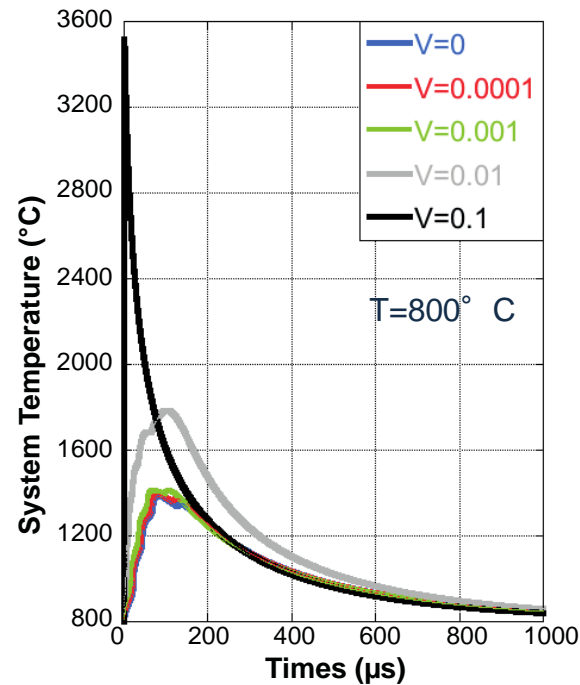
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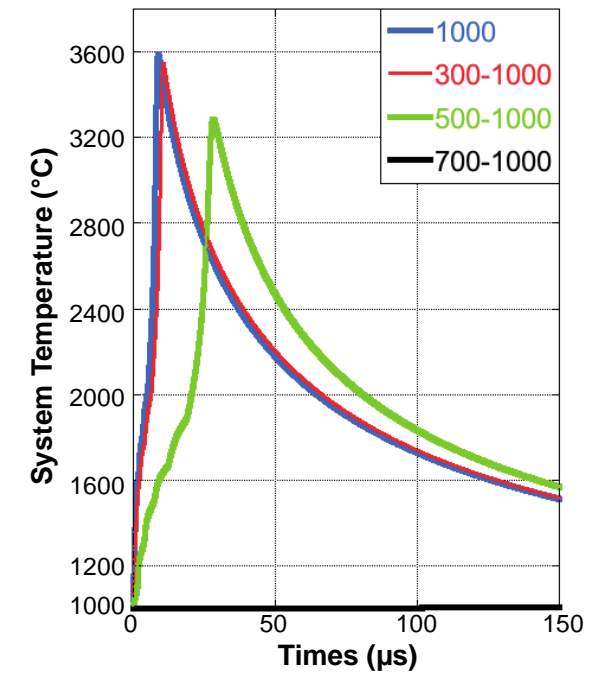
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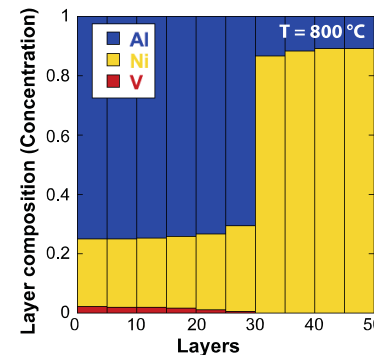
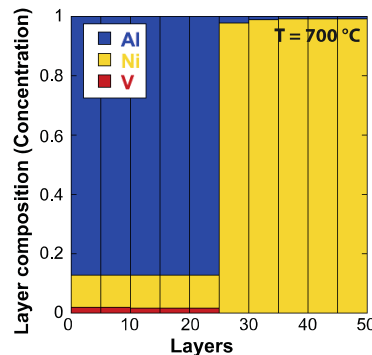
### ◆ Influence [Vacancies]



### ◆ Premixing layer Influence



### ◆ Layers composition



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En review à JAP

- Defects: incoming from deposition process
- Premixing layer
- Impact on final properties
- Process Simulation

Growth of reactive materials  
Kinetic Monte Carlo with Hot Atoms Trajectories

→ **Multiscale Modeling of technological process** (oxidation, vapor deposition)

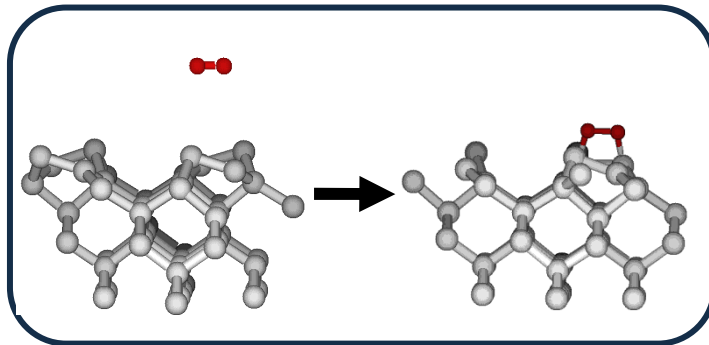
**Process Scale**

**KINETIC MONTE CARLO**

*Up to millions of atoms, Time scale: seconds*  
**Material growth as a function of temperature and pressure**

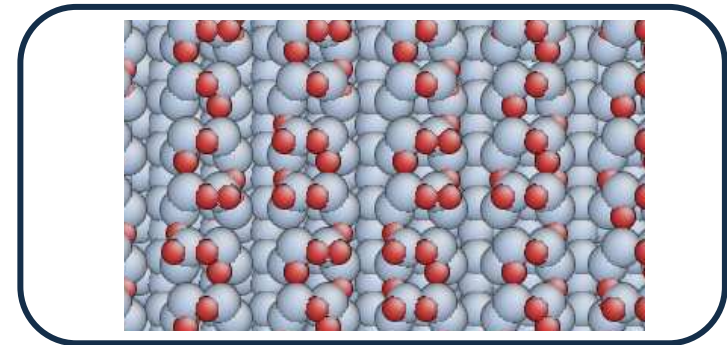
**DFT**

*Up to 200 atoms, Time scale: picoseconds*  
**Local Mechanisms**



*Growth phenomena*

*Structures,  $E_{ac}$*



*IR, STM*

*Characterization,  
Process,  
Technology...*

*XPS, AES, TEM, EDX ...*

**EXPERIMENTS**

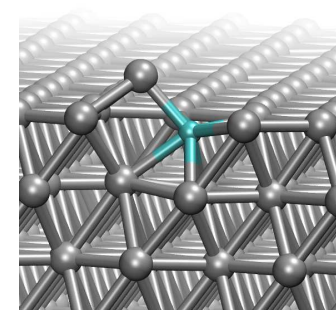
## Growth of reactive materials Kinetic Monte Carlo with Hot Atoms Trajectories

### Technology and modeling of reactive composite materials and systems

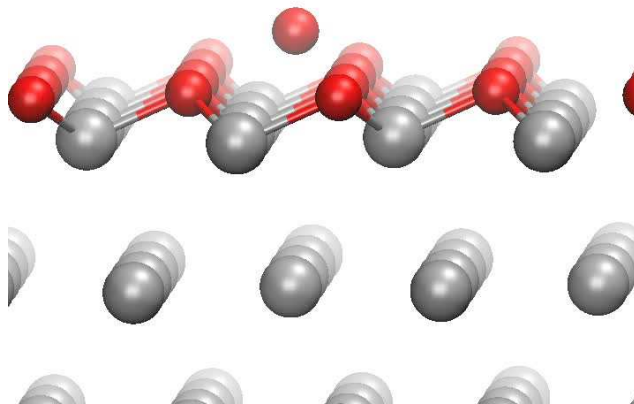
➤ **Al-CuO nanolaminates: basic mechanisms of CuO/Al PVD growth through first principles calculations (DGA-REI funding)**

- Mechanisms and energetics using DFT calculations of:
  - Al adsorption and penetration path on CuO
  - Dissociative chemisorption of CuO on Al (+ O, Cu separation)
  - Cu aggregation and penetration
  - Al extraction through oxygen exposure → Al oxidation
  - Partial order and orientation of grown alumina ultrathin layer

Cu on Al



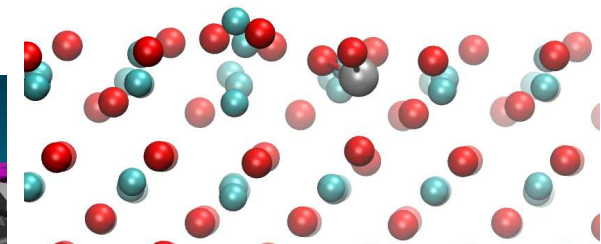
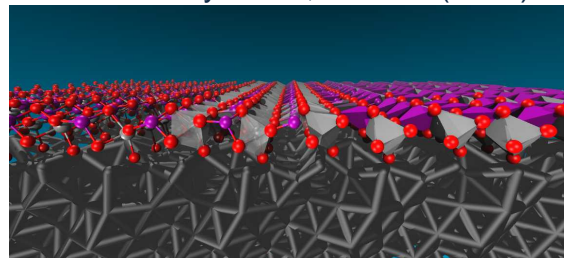
Thin Solid Films **520**, 4768 (2012)



O on Al

Al oxide after 2 ML of Oxygen  
atom deposition

J. Chem. Phys. **137**, 094707 (2012)



Al on CuO

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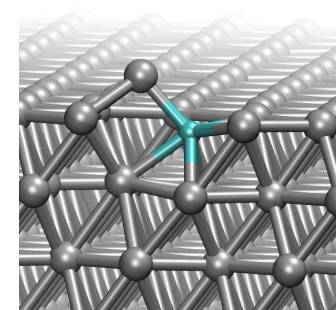
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➤ Al-CuO nanolaminates: basic mechanisms of CuO/Al PVD growth through first principles calculations (DGA-REI funding)

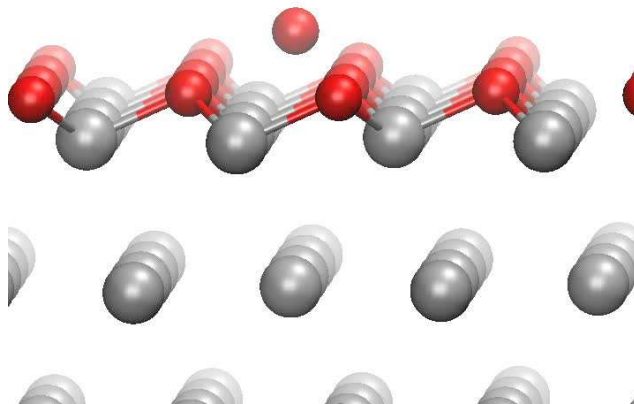
• Mechanisms and energetics using DFT calculations of:

- Al adsorption and penetration path on CuO **5.1 + 2.3 eV**
- Dissociative chemisorption of CuO on Al (+ O, Cu separation) **6.6 eV**
- Cu aggregation and penetration **3.15 + 0.55 eV**
- Al extraction through oxygen exposure → Al oxidation **5-8 eV**
- Partial order and orientation of grown alumina ultrathin layer

Cu on Al



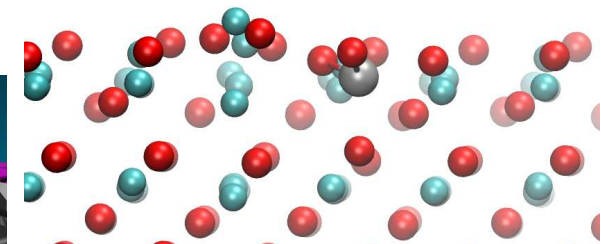
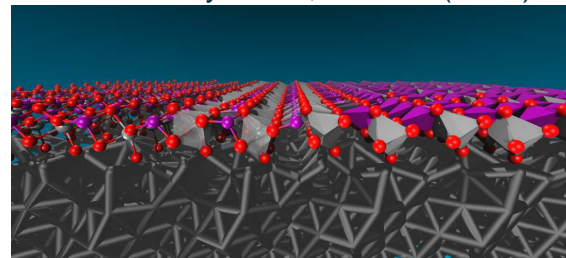
Thin Solid Films **520**, 4768 (2012)



O on Al

Al oxide after 2 ML of Oxygen  
atom deposition

J. Chem. Phys. **137**, 094707 (2012)

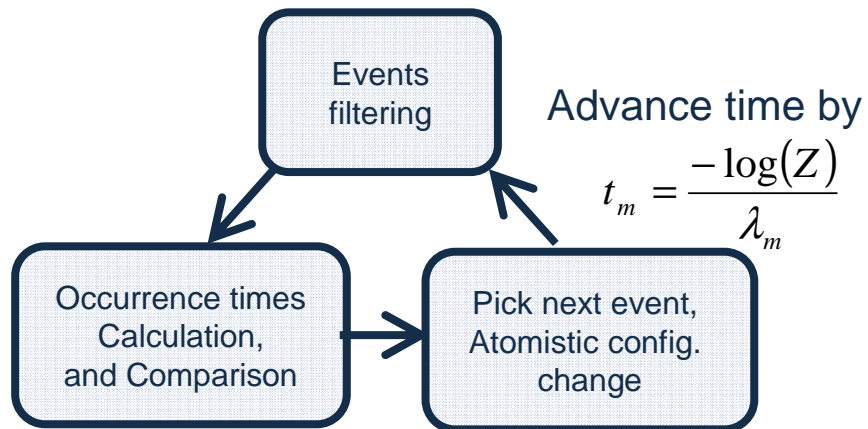


Al on CuO

# Growth of reactive materials Kinetic Monte Carlo with Hot Atoms Trajectories

## Limitation of conventional kMC

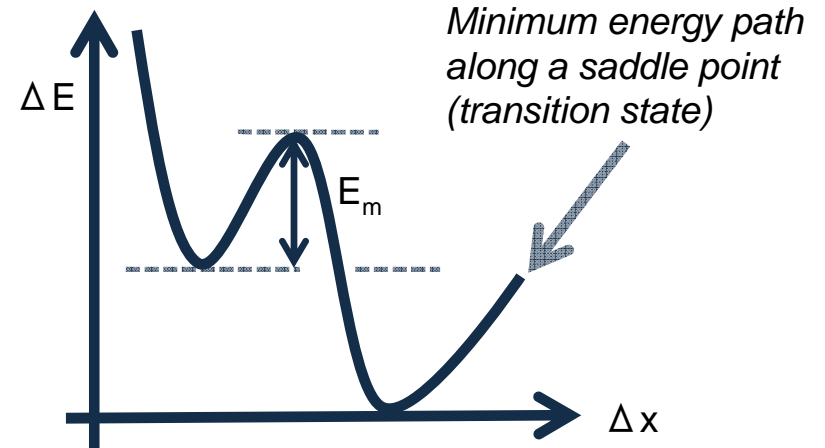
➤ No more valid when 'reactive' materials → why?



Arrhenius law derived acceptance

$$\lambda_m = v \cdot \exp\left(-\frac{E_m^\ddagger}{k_B T}\right)$$

Transition state theory



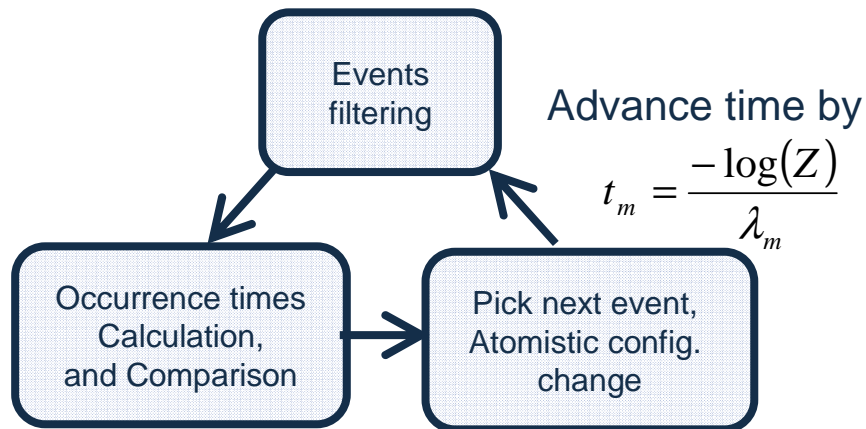


# Growth of reactive materials

## Kinetic Monte Carlo with Hot Atoms Trajectories

### Limitation of conventional kMC

➤ No more valid when 'reactive' materials → why?

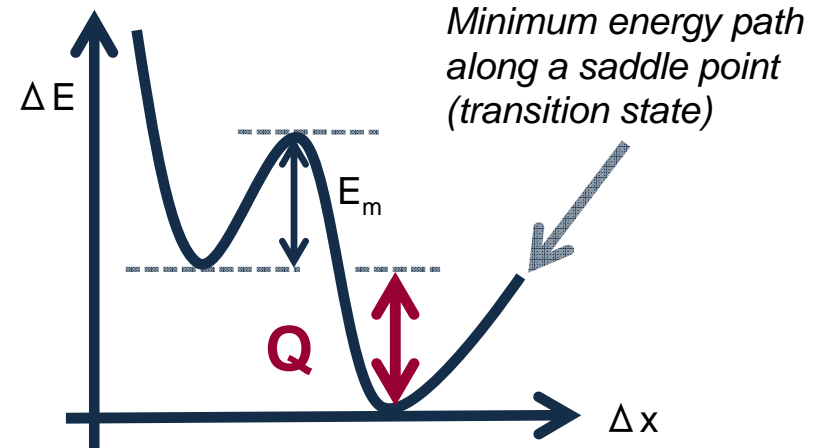


**Local reactions involving atoms carrying extra energy**

Arrhenius law derived acceptance

$$\lambda_m = v \cdot \exp\left(-\frac{E_m^\ddagger}{k_B T}\right)$$

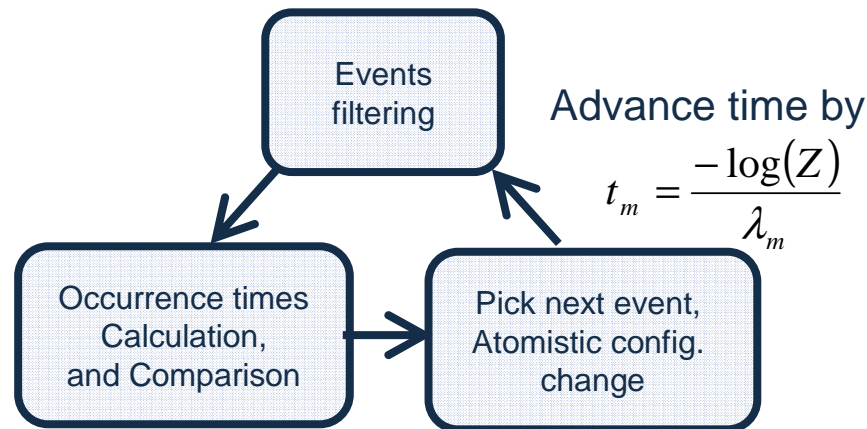
Transition state theory



Growth of reactive materials  
Kinetic Monte Carlo with Hot Atoms Trajectories

**Limitation of conventional kMC**

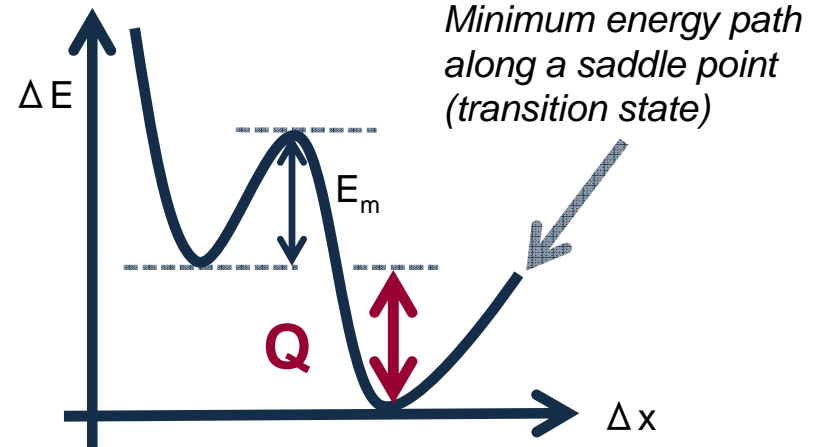
➤ No more valid when 'reactive' materials → why?



Arrhenius law derived acceptance

$$\lambda_m = v \cdot \exp\left(-\frac{E_m^\ddagger}{k_B T}\right)$$

Transition state theory



**Local reactions involving atoms carrying extra energy**

KMC procedure no more valid when energetic particles are introduced  
Energy release can not be neglected

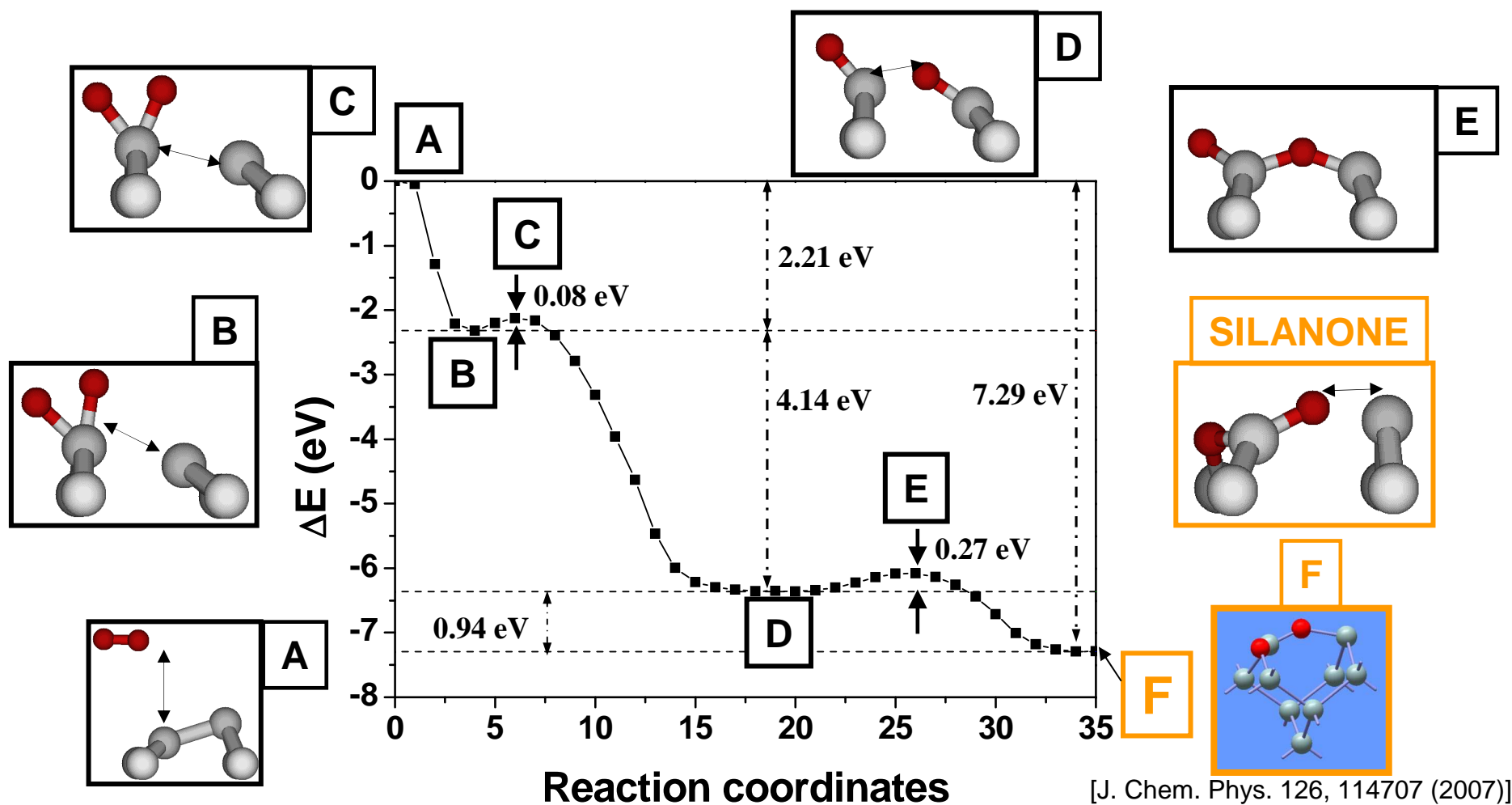
New KMC approach  
Coupling motion of the energetic atom to the vibrational state of the system

# Growth of reactive materials

## Kinetic Monte Carlo with Hot Atoms Trajectories

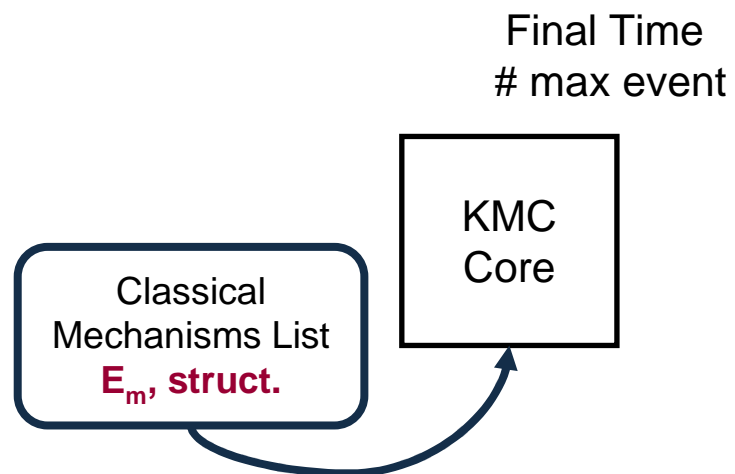
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## Growth of reactive materials Kinetic Monte Carlo with Hot Atoms Trajectories

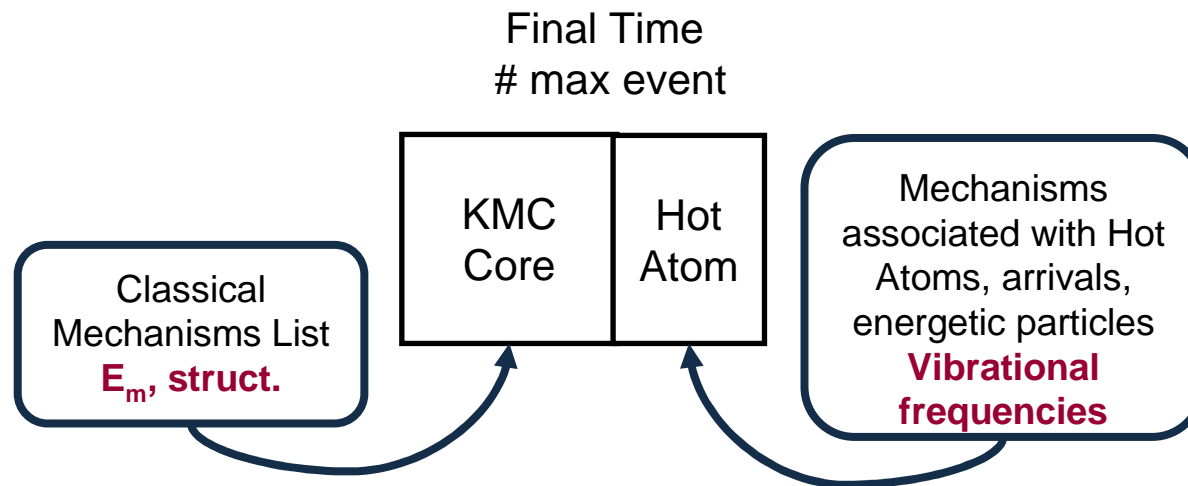
➤ Hyperthermal module for the treatment of atomistic motions and mechanisms related to exothermic reactions



◆ Jump driven by activation barrier

## Growth of reactive materials Kinetic Monte Carlo with Hot Atoms Trajectories

➤ Hyperthermal module for the treatment of atomistic motions and mechanisms related to exothermic reactions



◆ Jump driven by activation barrier

◆ Coupling motion of the hyperthermal atom to the vibrational state of the system (phonons)  
→ trajectories

Each normal mode is defined by a vibration angular frequency  $\omega$  and a reduced displacement vector

$$|u(t)\rangle = \sum_{k,p} A_{(k,p)} e^{i(k \cdot u - \omega t)} |k, p\rangle e^{-t/\tau} + c.c.$$

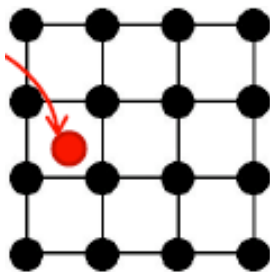
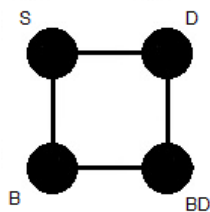
$$A_{(k,p)} = f(u(o), v(o))$$

# Growth of reactive materials

## Kinetic Monte Carlo with Hot Atoms Trajectories

➤ Hyperthermal module for the treatment of atomistic motions and mechanisms related to exothermic reactions

- **Validation** on a 2D scheme coupled with analytical phonon description



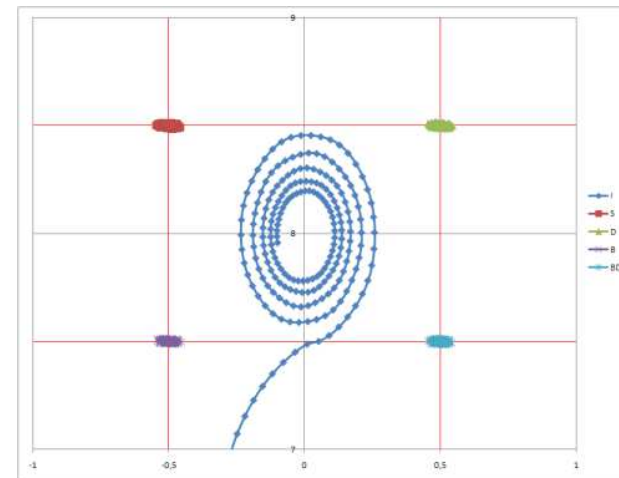
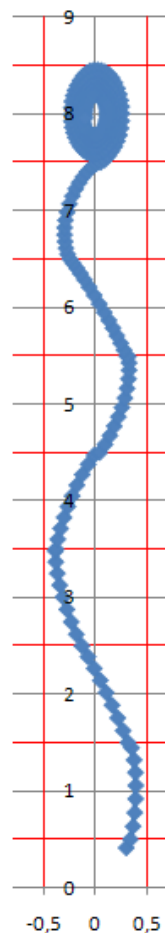
**KMC includes:**

Migrations

Defect generation

One vacancy can be created

Only on the 4 nearest neighbour sites

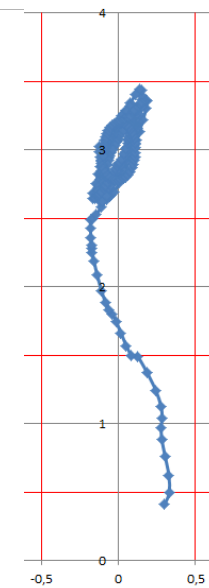
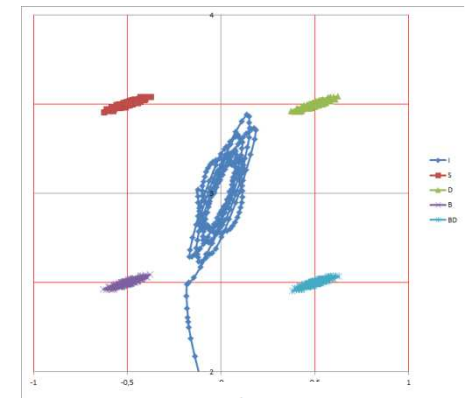
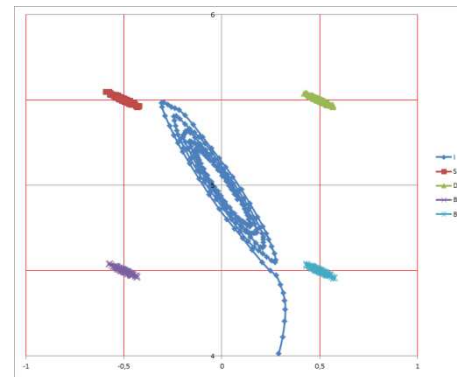
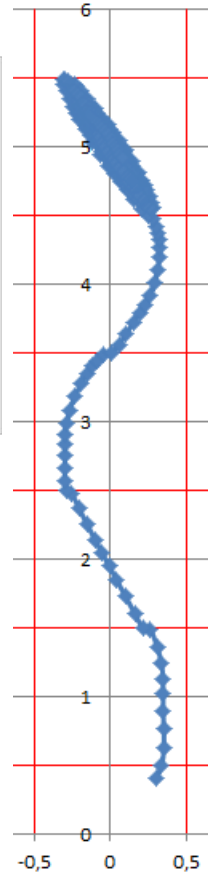
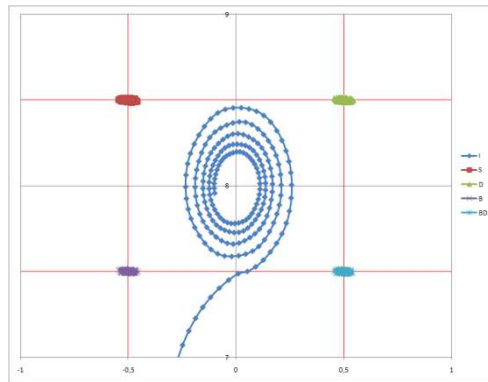
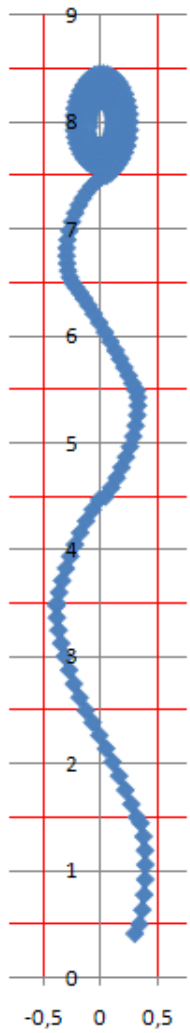


**Hyperthermal migration and trapping of an Interstitial atom**

# Growth of reactive materials

## Kinetic Monte Carlo with Hot Atoms Trajectories

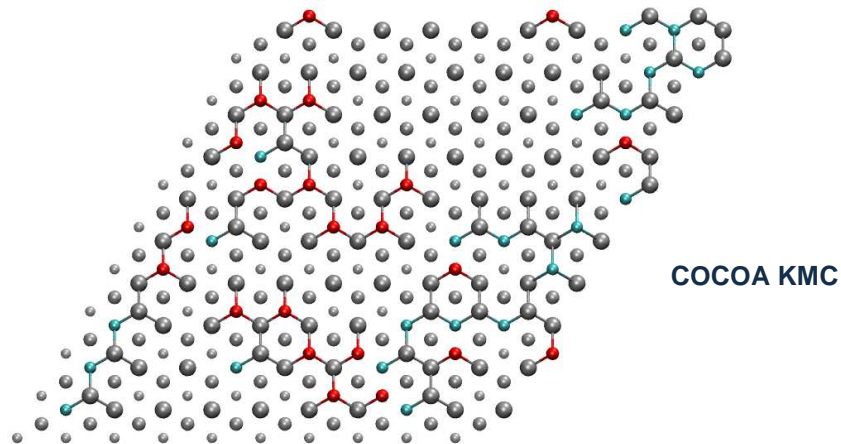
➤ Hyperthermal module for the treatment of atomistic motions and mechanisms related to exothermic reactions



## Growth of reactive materials Kinetic Monte Carlo with Hot Atoms Trajectories

### Conclusions

- New methodology to deal with exothermic reactions in kMC procedure



- Applications

- ◆ Mechanisms occurring in material oxidation (Si, Al)
- ◆ Deposition and ignition of nanostructured energetic materials, such as bimetallic (Ni/Al) or metal-oxide (CuO/Al) layers
- ◆ Creation of defects under energetic radiations effects (NIEL: Non Ionizing Energy Loss) as in electronic devices in harsh environments, particularly in spatial applications or subject to solar wind.



Growth of reactive materials  
Kinetic Monte Carlo with Hot Atoms Trajectories

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**Thank you**

**Sujet de thèse proposé au LAAS-CNRS**

- ◆ **“ Vers une intégration optimisée des matériaux énergétiques :  
Modélisation multi-échelles et multi-physiques de la croissance de  
multicouches Al/CuO “**
- ◆ A diffuser largement ... Merci